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LIST OF RELEVANT ART CITED BY APPLICANT

(Use several sheets if necessary)

Applicant(s):

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Filing Date:

04/26/01

Group:

3723

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
DVN	AA	4,031,038/	06/21/77	Grinstead et al.			
DVN	AB	6,207,630 B1/	01/27/01	Vaartstra			
	AC						
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Foreign Patent Documents

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		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

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Date Considered

Dung van Nguyen

5-24-2002

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.